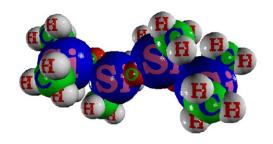


DOWSILTM Silicone NIL (Nano-Imprinting Lithography) mold materials

The unique properties of silicones



Molecular characteristics

- Highly open, flexible and mobile backbone
- High bond strength: 435 kJmol-1 Si-O, cf. 350 kJmol-1 C-C

Physico-chemical properties

- · Low surface tension and energy
- · High spreading and wetting capabilities
- · Permeable to gas and water vapour
- · Heat stability
- Degradability
- · Compatibility with organics
- · Weather resistance
- · Low glass transition temp.

Applications

- Lubricant
- Antifoam agent
- · Release agent
- · Aesthetic feel (softness)
- Comfort
- · High temperature processing
- · Can be sterilized
- Hydrophobic / hydrophilic
- Breathable

Nanoimprint process (heat or UV cure)

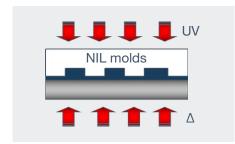
1. Spin coat



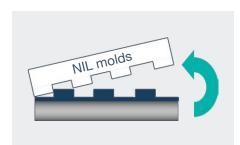
2. Imprint



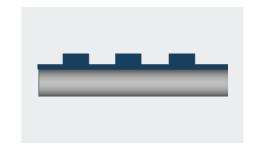
3. Cure (heat or UV)

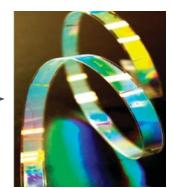


4. Demoulding



5. Pattern replicated





Silicone-Based NIL Mold: s-PDMS

Soft-PDMS (s-PDMS)

• Sylgard 184: control

• High modulus SG184: 5, 10, 15 MPa

• Viscosity range: 1,000 to 5,000 cP

• Two-part solution (shelf-life: > 2 year at RT)

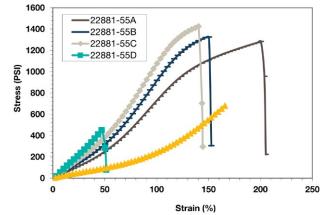
• One-part solution (shelf-life: > 6month/ 3-5°C)

• Low-temperature heat cure: 70 - 80°C

R&D	Mechanical properties after cure			
Sample #	Hardness	Young	Tensile	Elogat%
	(Shore A)	modulus (MPa)	(psi)	Average
SG184	50	1.8	1022	230
22881-55A	68	4.1	1307	206
22881-55B	71	5.1	1339	150
22881-55C	74	6.5	1376	138
22881-55D	78	7.6	426	47
23610-51B1	79	10.0	696	41
23610-51B2	82	12.0	435	16
23610-51B3	85	15.3	357	16

Example of flexible NIL mold structure



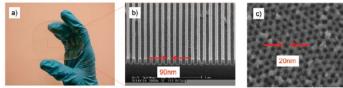


Silicone-Based NIL Mold: h-PDMS

UV-curable h-PDMS (hard-PDMS)

- Fluro-silicone composition for facile demolding
- High modulus (> 30MPa) / hardness (> 3H)
- Solvent-free composition
- Viscosity: 50-500 cP
- Fast UV-cure at RT (< 5 seconds)
- · Uniform liquid film by spin-coating, or spray coating

UV-cure	Cured resin	
UV-broadband at RT	Modulus*: 0.3-2.18 GPa	
UV dosage: <0.5 J/cm ²	Hardness*: 0.05-0.15 GPa	
Cure time: <3 second	Shrinkage < 3%	
	UV transmittance > 90%	



Fluor-silicone mold on PET made from SiO₂ master mold and patterned structures

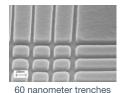
Dow offering

NIL mold material solutions

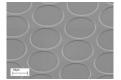
- S-PDMS
- Low-T heat cure
- H-PDMS
 - UV-cure
- · Other Silicone materials

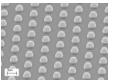
UV-cure low-viscosity silicone for NIL

Enabling large patterning at low pressure









Customized solution

Image: dow_40366216122

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